

REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2800
Docket No. 1514.1010

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Woo Young SO et al.

Serial No. 10/068,004

Group Art Unit: 2826

Confirmation No. 6442

Filed: February 8, 2002

Examiner: Ahmed N. Sefer

For: THIN FILM TRANSISTOR AND MANUFACTURING METHOD THEREOF, AND ACTIVE
MATRIX DISPLAY DEVICE AND MANUFACTURING METHOD THEREOF

**REQUEST FOR COMPLETE OFFICE ACTION AND
RESTARTING OF PERIOD FOR RESPONSE**

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Final Office Action mailed November 7, 2007, and having a period for response set to expire on February 7, 2008.

The Final Office Action of November 7, 2007, is incomplete because it does not consider the Request for Continued Examination (RCE) and the Amendment Accompanying Request for Continued Examination (RCE) filed on October 31, 2007. The undersigned attorney pointed this out to Examiner Ahmed N. Sefer in a telephone discussion on November 8, 2007, and the Examiner said that he would issue a complete Office Action considering the RCE and the Amendment filed on October 31, 2007. However, according to the image file wrapper of the application, the complete Office Action had not yet been issued as of the filing date of this paper.

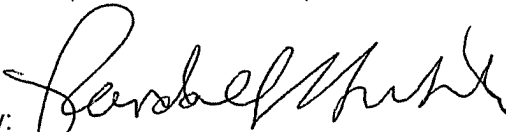
Accordingly, pursuant to MPEP 710.06, it is respectfully requested that a complete Office Action considering the RCE and the Amendment filed on October 31, 2007, be issued, and that the period for response be restarted.

If there are any additional fees associated with the filing of this paper, please charge the same to our Deposit Account No. 503333.

Respectfully submitted,

STEIN, MCEWEN & BUI, LLP

Date: 12/03/07

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